



ECLLOUD Model Development for Shielded Pickup Measurements of Electron Cloud Development in an Uncoated Aluminum Vacuum Chamber

First model developed 10/2010 (see ECLLOUD10 and EC Simulation Planning Meeting 3/11/2011)

Many modeling improvements since then:

- 1) Synrad3D photon rates and absorption site distributions*
- 2) Flexible photoelectron generation model (QE and energy distribution)*
- 3) More sophisticated, tuned SPU acceptance functions and hole secondary generation*
- 4) More accurate CESR vacuum chamber profile including vertical side walls*

Preparation for upcoming SPU data-taking with unconditioned bare and TiN-coated aluminum v.c. at 15E/W.

Jim Crittenden, Emily Hemingway (NSF REU Program) & John Sikora

Cornell Laboratory for Accelerator-Based Sciences and Education

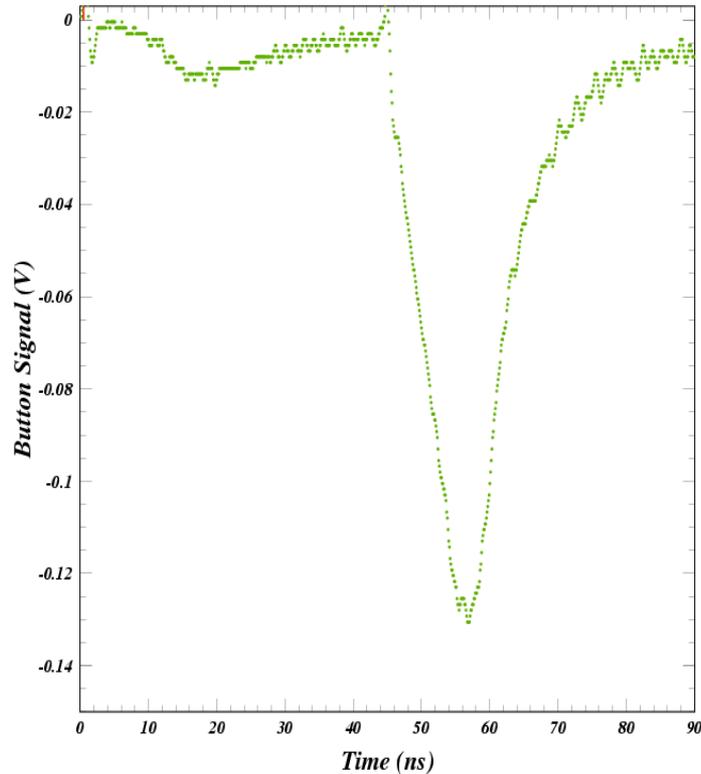
Electron Cloud Meeting

15 August 2012

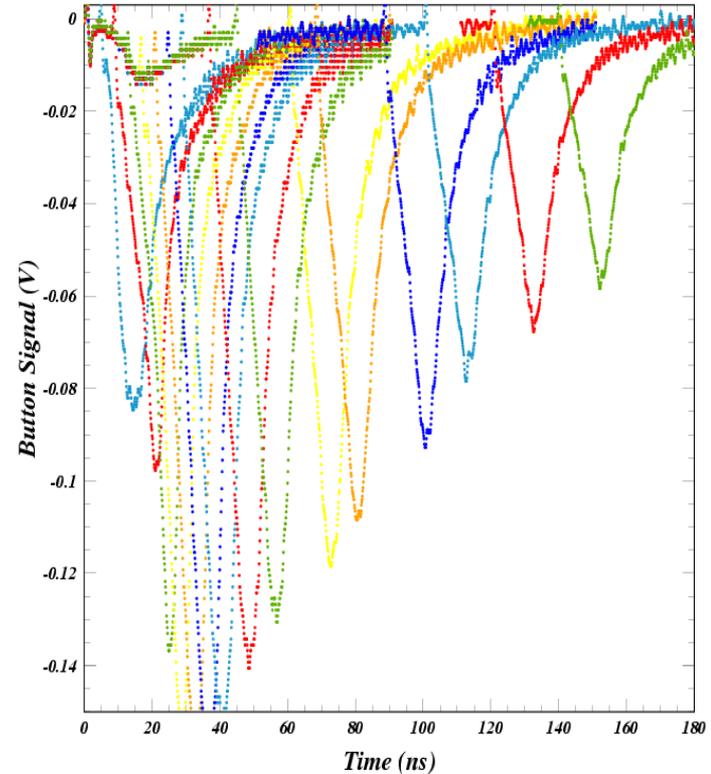




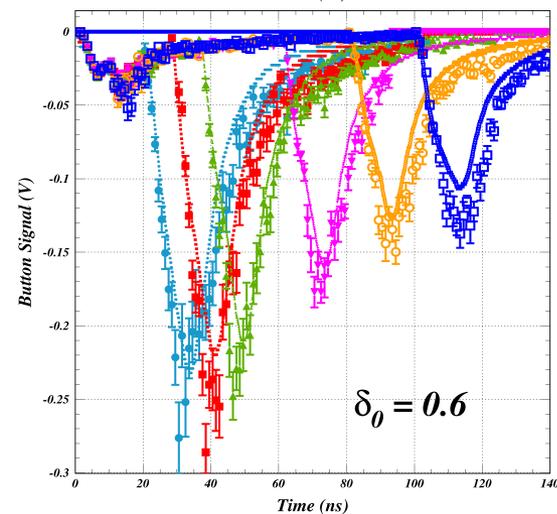
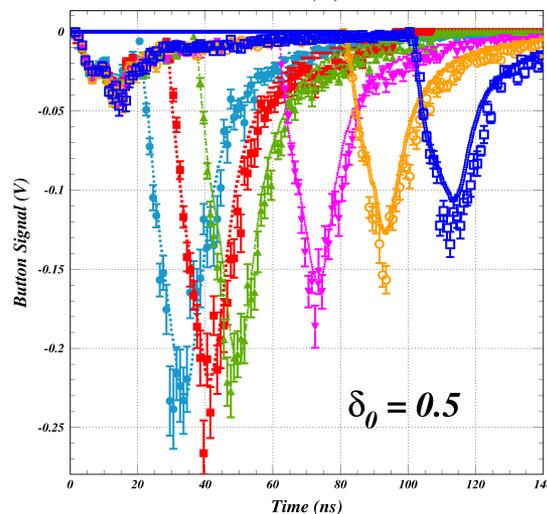
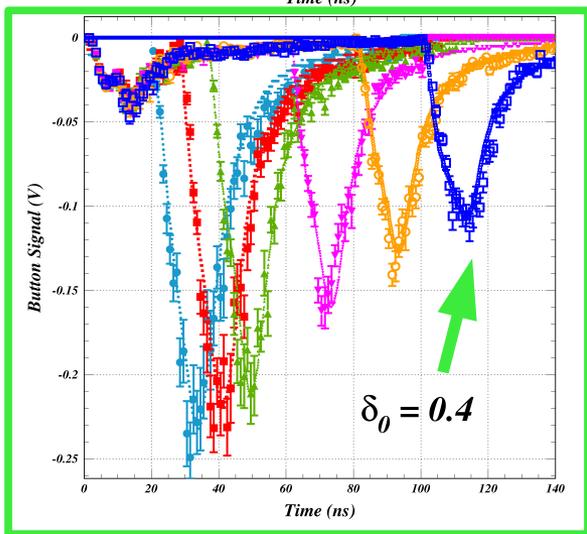
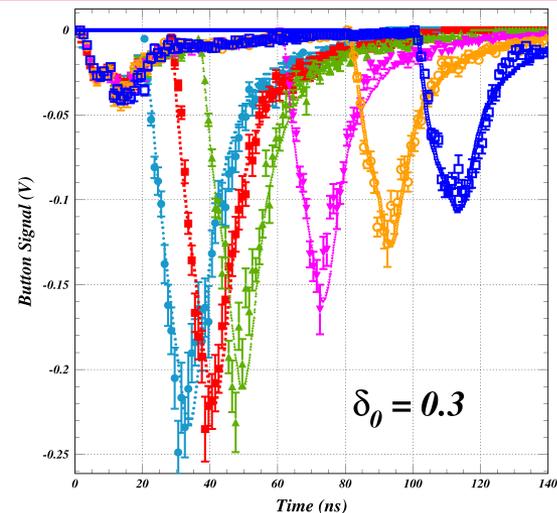
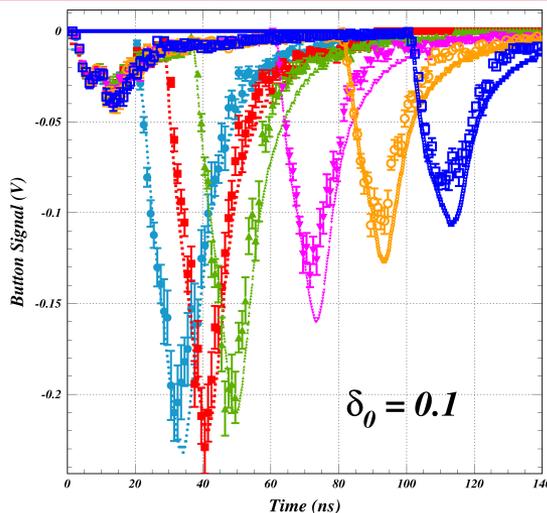
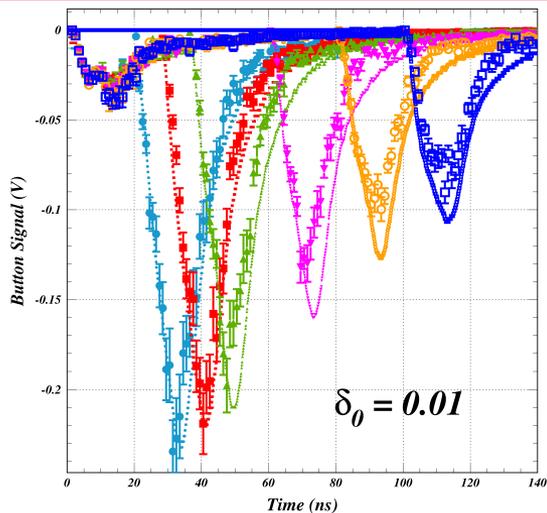
*Shielded pickup scope trace
for two bunches 44 ns apart*



*Superposition of 15 such traces
illustrating the sensitivity to cloud lifetime*



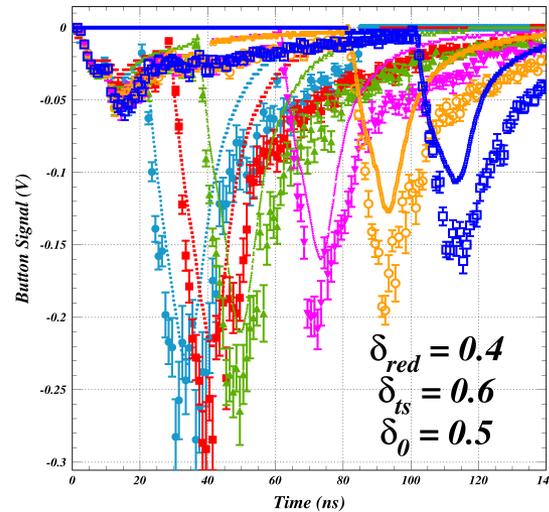
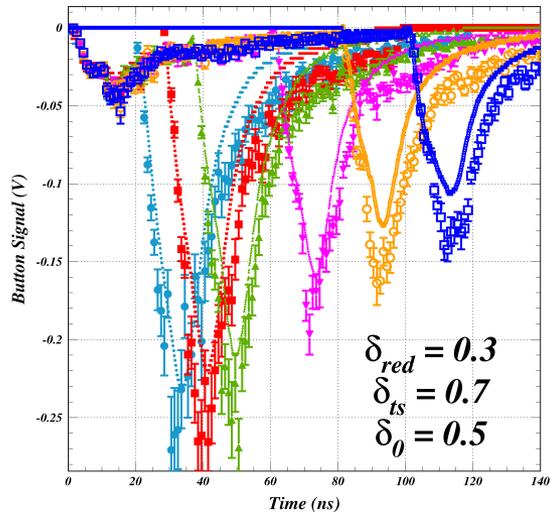
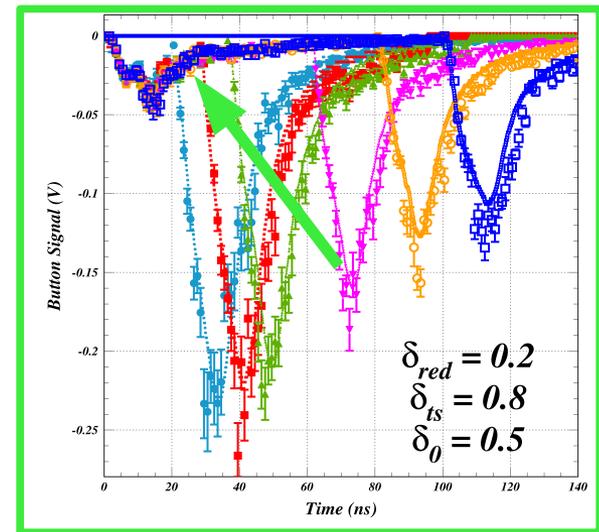
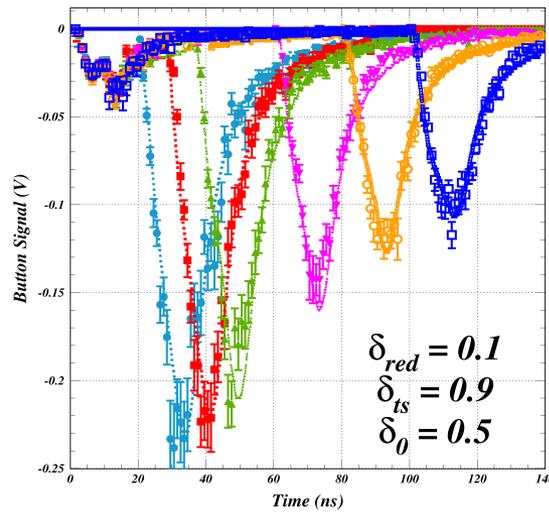
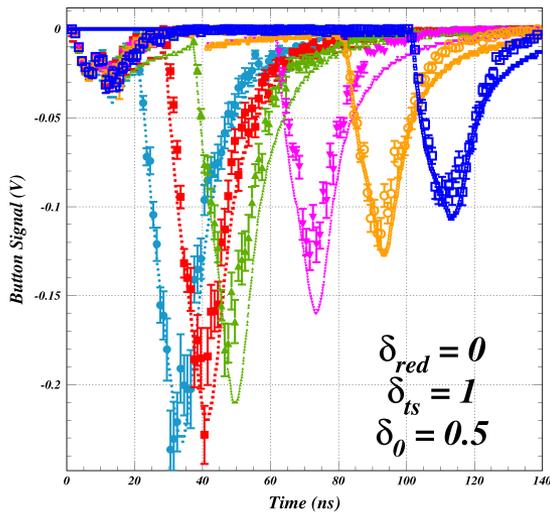
The single bunch signal arises from photoelectrons produced on the bottom of the vacuum chamber. Its shape is closely related to the photoelectron kinetic energy distribution and the beam kick. The witness bunch signal includes the single-bunch signal as well as the that produced by cloud particles accelerated into the shielded pickup by the kick from the witness bunch. The witness signal is therefore sensitive to the SEY model.



Satisfactory result after exhaustive parameter search (6 weeks!), but true secondary yield value LOW ($\delta_{ts} = 0.8$!)



Discriminating between the true and rediffused secondary yield processes



The rediffused secondary yield process determines the trailing edge of the signal from a single bunch.

This trailing edge is insensitive to δ_0 .

The late witness bunch signal used to determine δ_0 is also sensitive to the rediffused yield process.

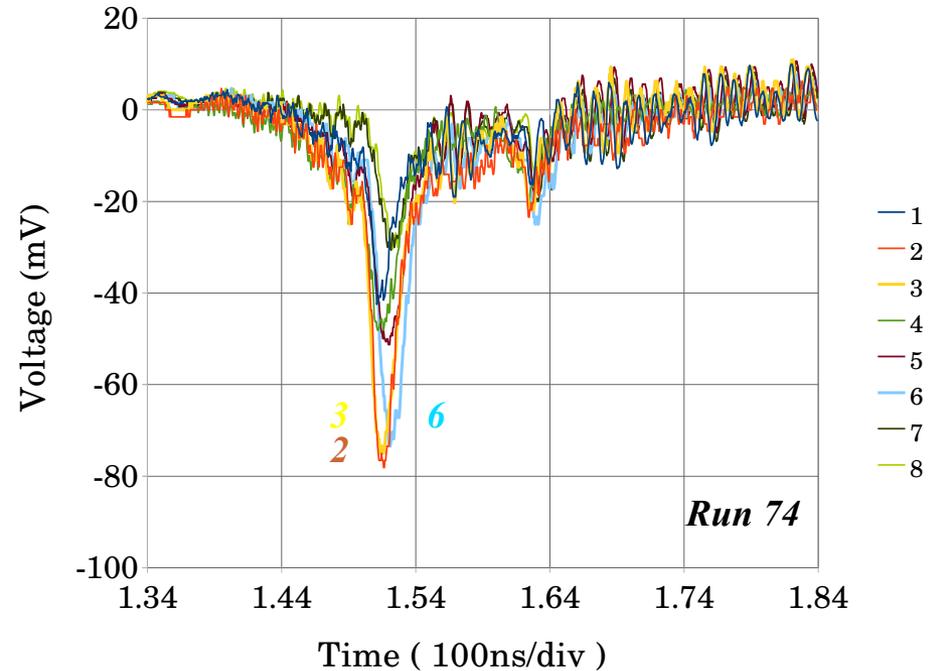
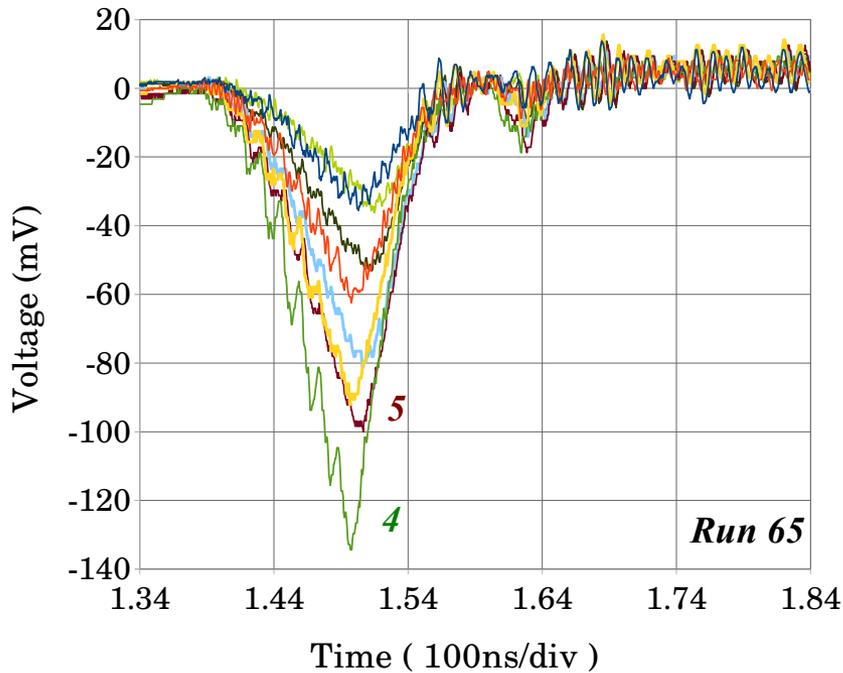
The witness bunch method does provide discriminating power between the true and rediffused processes. But work remains to understand the low optimized value for the true secondary yield.



- *Continue work on the present model for uncoated aluminum.*
 - ➔ *It is a poor match to the data for bunch spacings less than 20 ns. Why?*
- *Develop the model for the TiN-coated vacuum chamber at 15W.*
 - ➔ *SPU measurements in a conditioned TiN-coated chamber at 15W were made 12/2010.*
- *Take full set of witness bunch measurements on new Al and TiN 8/23-24.*
 - ➔ *Immediate comparison to the model to see if SEY yields are high.*
 - ➔ *Repeat in November to see conditioning effects.*
- *Develop a model for the time-resolved RFA detectors in L3.*
 - ➔ *SPU acceptance functions and collector definitions needed.*



3/13/2012 5.3 GeV e+ 10 bunches 8 mA/bunch Al (L3#4)



Chicane dipole field off

Central collectors dominate.

Chicane dipole field 45 G

Central collectors show a depletion zone.
This is known to arise from the peak of the SEY curve and provides information on E_{\max} .